

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/649,738	CHOI ET AL.	
Examiner	Art Unit	
Mike Qi	2871	

	SEARCHED					
Class	Subclass	Date	Examiner			
349	123 132-134, 172 99-100	11/9/2006	ZQQ			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East search US-PGPUB;USPAT;USOCR;FPRS, EPO;JPO;DERWENT;IBM_TDB; update search (see printout)	11/9/2006	ZQQ	